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OPTICA APPLICATA

Vol. XXXII (2002) No. 1–2

PL ISSN 0078-5466

Index 367729

A joint publication of the

INSTITUTE OF PHYSICS,
WROCLAW UNIVERSITY
OF TECHNOLOGY,
POLAND

&

SPIE/POLAND CHAPTER
in association with
SPIE – THE INTERNATIONAL SOCIETY
FOR OPTICAL ENGINEERING

Contents

Editorial	5
ABRAMSKI K.M., TRZASKA H., Photonic electromagnetic field sensor developments	7
GRZEGORZEWSKI B., KOWALIŃSKA E., GÓRNICKI A., GUTSZE A., Diffraction measurement of erythrocyte sedimentation rate	17
SARNOWSKA-HABRAT K., DUBIK B., ZAJĄC M., Visual acuity in polychromatic light	25
CZERWIŃSKI M., MROCZKA J., Hybrid method – the case of arbitrary particle size distribution	35
BADZIAK J., JABŁOŃSKI S., MAKOWSKI J., PARYS P., RYC L., VANKOV A.B., WOŁOWSKI J., WORYNA E., JUHA L., KRASA J., X-ray emission from high-intensity interaction of picosecond and subnanosecond laser pulses with solid targets ...	41
KRYSZCZYŃSKI T., Exact algebraic method for design of the model nonastigmatic spherical ophthalmic glasses	47
SZYJER M., KRASKA Z., KOWALIK A., Modulated gratings and grating-modulated holograms: their spectral and polarization properties and protection possibilities	61
PIEŃKOWSKI J., RZEPKA J., SAMBOR S., System for calibration of the frequency stabilized He-Ne laser	75
COJOCARU E., Temporal pulse response of quasi-periodic Fibonacci Fabry–Perot type optical filters	85
DROBNIK A., NOWAK P., Electron microscopic analysis of the structure of the silver halide light-sensitive layers	93
NOWAK P., RAJKOWSKI B., Review of empirical models of photographic recording of image information	103
RAJKOWSKI B., Influence of the rate of photographic development process on the edge effects	113
RAJKOWSKI B., LATA CZ L., Model examination of the influence of edge effects on the acutance of photographic image	121
HOFFMAN J., SZYMAŃSKI Z., Absorption of the laser beam during welding with CO ₂ laser	129
POKUTNYI S.I., SALEJDA W., JACAK L., MISIEWICZ J., TYC M., Nanolaser on heavy hole transition in semiconductor nanocrystals	147

NAKWASKI W., MAĆKOWIAK P., OSIŃSKI M., Simulation of thermal properties of proton -implanted top-surface-emitting lasers. I. Analytical thermal model	157
NAKWASKI W., MAĆKOWIAK P., OSIŃSKI M., Simulation of thermal properties of proton -implanted top-surface-emitting lasers. II. Results and discussion	173
TIESLER M.M., WITKOWSKI J.S., ABRAMSKI K.M., Quality criterion for numerical methods in EDFA modelling	187

Letters to the Editor

SIUZDAK J., Fast thinning algorithm ready for real-time application	197
MAGIERA A., Cut-off spatial frequency in a confocal microscope with trigonometric filters in its pupil	201
WYSOCKI G., ABRAMSKI K.M., Frequency stabilisation of twin orthogonal mode He-Ne laser	207

Editorial

It is our pleasure to inform you that a growing recognition of our quarterly among the specialists working in the field of optics and optoelectronics throughout the world has been observed in recent years. This is manifested, among others, in two facts:

- our journal has been placed on the well known Philadelphia ranking list
- for a long time *Optica Applicata* has been cited and/or indexed in the main international abstracting publications.

Also, we are delighted to notice a rapid increase of the number of papers submitted for publication in our quarterly, which resulted in a significant practical broadening of the subject matter of our journal. Therefore, we come to the conclusion that this situation necessitates some modernisation of the functioning concept of both the Editorial Office and the Editorial Board as well as the due redefinition of their mutual relations.

In particular, we felt that there was an urgent need for changing the functioning principles of the former Editorial Board and replacing it by a new Institution named International Advisory Board in the hope that its members would like both to have greater influence on and to take greater responsibility for the merit and scientific level of the papers submitted for publication in *Optica Applicata*. It is our great honour to announce that a number of distinguished Scientists accepted our invitation to the membership of the International Advisory Board. We are deeply convinced that the great experience in research and editing activities of the newly created International Advisory Board will generate new ideas improving both the scientific and editorial level of our journal and in this way allow us to fully meet the needs of the International Optical Community, which is our only goal.

May I express my hearty thanks and high respect to both the new and old outstanding members of the new Board for their declared will of co-operation with the Editorial Office of *Optica Applicata* to the benefit of both the authors and the readers of our common work known as *Optica Applicata*.

Dr. Ireneusz Wilk
Editor in Chief